

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

2675

In re the Application of

Satoshi INOUE et al.

Application No.: 09/899,058

Filed: July 6, 2001

Docket No.: 110041

For: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURE

INFORMATION DISCLOSURE STATEMENTDirector of the U.S. Patent and Trademark Office
Washington, D.C. 20231

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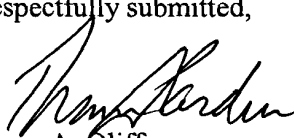
Technology Center 2600

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. The references were cited in a counterpart foreign application. An English language version of the foreign search report is attached for the Examiner's information.

Respectfully submitted,


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Date: June 26, 2002

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